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Colleen J. Dew 3/16/2004

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit 1752

OFFICIAL

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| <u>In re application of</u> | : | March 16, 2003 |
| Wenjie Li et al. | : | Examiner: Sin J. Lee |
| Serial No. : 10/026,120 | : | |
| Filed: December 21, 2001 | : | IBM Corporation |
| Title: POSITIVE RESIST | : | Dept. 18G/Bldg, 300-482 |
| COMPOSITIONS CONTAINING | : | 2070 Route 52 |
| NON-POLYMERIC SILICON | : | Hopewell Junction, NY |
| ADDITIVES | : | 12533-6531 |

Amendment

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendment is submitted in response to the final office action dated January 8, 2004.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

Please
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(3-29-04)